



AF / 1763  
IFW

Docket No.: 50099-183

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Seiichiro OKUDA, et al.	:	Confirmation Number: 4482
Serial No.: 09/973,182	:	Group Art Unit: 1763
Filed: October 10, 2001	:	Examiner: Sylvia Macarthur
For: SUBSTRATE PROCESSING APPARATUS	:	

AMENDMENT

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action dated March 2, 2004, reconsideration is requested in view of the following remarks: